

Haruo Sudo

List of Publications by Year in descending order

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papers

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citations

2258059

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2272923

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#	ARTICLE	IF	CITATIONS
1	Formation behavior of oxygen precipitates in silicon wafers subjected to ultra-high-temperature rapid thermal process. <i>Journal of Applied Physics</i> , 2022, 131, 055704.	2.5	1
2	Point Defect Reaction in Silicon Wafers by Rapid Thermal Processing at More Than 1300Å°C Using an Oxidation Ambient. <i>ECS Journal of Solid State Science and Technology</i> , 2019, 8, P35-P40.	1.8	5
3	Control of grown-in defects and oxygen precipitates in silicon wafers with DZ-IG structure by ultrahigh-temperature rapid thermal oxidation. <i>Journal of Applied Physics</i> , 2018, 123, 161591.	2.5	6
4	Impact of Rapid Thermal Oxidation at Ultrahigh-Temperatures on Oxygen Precipitation Behavior in Czochralski-Silicon Crystals. <i>ECS Journal of Solid State Science and Technology</i> , 2013, 2, P66-P70.	1.8	12